

**Initial Information Data Sheet**

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**Inventor Information**

Inventor One Given Name: Takayuki  
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Postal Address Line One: c/o Tokyo Electron Kyushu Limited,  
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Inventor Two Given Name: Miyako  
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**Correspondence Information**

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### Application Information

Title Line One:	METHOD AND APPARATUS OF
Title Line Two:	PROCESSING SURFACE OF SUBSTRATE
Total Drawing Sheets:	10
Formal Drawings?:	Yes
Application Type:	non-provisional
Docket Number:	199372003600

### Representative Information

Representative Customer Number:

### Continuity Information

This application is a:

> Application One:

Filing Date:

which is a:

>>Application Two:

Filing Date:

which is a:

>>>Application Three:

Filing Date:

### Prior Foreign Applications

Foreign Application One:	2000-320646
Filing Date:	October 20, 2000
Country:	Japan
Priority Claimed:	Yes

### Assignee Information

Assignee:	TOKYO ELECTRON LIMITED
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